



1771

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
HIROKATSU MIYATA) : Examiner: Hai Vo
Application No.: 09/657,616) : Group Art Unit: 1771
Filed: September 8, 2000) :
For: MESOSTRUCTURED THIN FILM,)
MESOPOROUS THIN FILM, AND)
PROCESS FOR PRODUCTION)
THEREOF : April 28, 2004

MAIL STOP NON-FEE AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

a) Introductory Comments

In response to the Official Action dated January 28, 2004, kindly amend the subject application as follows:

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

April 28, 2004
(Date of Deposit)

PETER SAXON (24947)
(Name of Attorney for Applicant)


Signature April 28, 2004
 Date of Signature